



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al.

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: R. Kunemund

For : A Method To Repair Localized Amplitude  
Defects In A EUV Lithography Mask Blank

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period  
for filing a reply in the above identified application.

The requested extension fee for a one month extension (37 CFR 1.17(a)(3) is  
\$950.

The Commissioner is hereby authorized to charge this fee (\$950) to Deposit  
Account Number 501913.

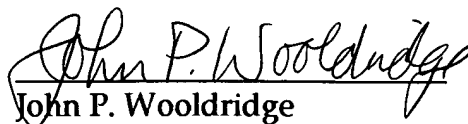
If any impediments remain, please contact the undersigned at 808-270-1011.

Respectfully submitted,

05/05/2004 MGE BREM1 00000031 501913 09896722

02 FC:1253 950.00 DA

Dated: April 27, 2003

  
John P. Wooldridge  
Attorney for Applicant  
Registration No. 38,725